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## BIB DATA SHEET

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## \*\* CONTINUING DATA \*\*\*\*\*

This application is a 371 of PCT/JP05/02352 02/16/2005

## \*\* FOREIGN APPLICATIONS \*\*\*\*\*

JAPAN 2004-038888 02/16/2004  
 JAPAN 2004-093703 03/26/2004  
 JAPAN 2004-093695 03/26/2004

\*\* IF REQUIRED, FOREIGN FILING LICENSE GRANTED \*\*  
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Foreign Priority claimed 35 USC 119(a-d) conditions met	<input checked="" type="checkbox"/> Yes <input type="checkbox"/> No	<input checked="" type="checkbox"/> Met after PD Intents	STATE OR COUNTRY JAPAN	SHEETS DRAWINGS 26	TOTAL CLAIMS 34	INDEPENDENT CLAIMS 4
Verified and Acknowledged /PHUC T DANG/ Examiner's Signature						

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## TITLE

THIN FILM TRANSISTOR, METHOD OF MANUFACTURING SAME, DISPLAY DEVICE, METHOD OF MODIFYING AN OXIDE FILM, METHOD OF FORMING AN OXIDE FILM, SEMICONDUCTOR DEVICE, METHOD OF MANUFACTURING SEMICONDUCTOR DEVICE, AND APPARATUS FOR MANUFACTURING SEMICONDUCTOR DEVICE

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